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Dated: September 28, 2004 Signature: _____

(Michelle Chicos)

DT04 10/509538
PCT/PTO 28 SEP 2004

Docket No.: 62121(70904)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kuniaki Okada et al.

Application No.: Not Yet Assigned

Confirmation No.: N/A

Filed: September 28, 2004

Art Unit: N/A

For: MICRO-LENS ARRAY SUBSTRATE AND
PRODUCTION METHOD THEREFOR,
AND PROJECTION TYPE LIQUID
CRYSTAL DISPLAY USING THOSE

Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement accompanies the new patent application submitted herewith.

A summary/abstract translation of the non-English language references is enclosed.

A copy of each reference on the PTO/SB/08 is attached.

A concise explanation of relevance of the items listed on form PTO/SB/08 is given for only non-English language listed items.

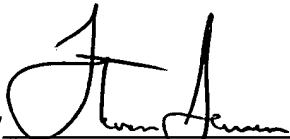
In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 04-1105, under Order No. 62121(70904). A duplicate copy of this paper is enclosed.

Dated: September 28, 2004

Respectfully submitted,

By 

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PTO/SB/08a/b (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

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Substitute for form 1449A/B/PTO				<div>Complete if Known</div> <div>10/509</div>	
<div>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</div> <div>(Use as many sheets as necessary)</div>				Application Number	Not Yet Assigned
				Filing Date	September 28, 2004
				First Named Inventor	Kuniaki Okada
				Art Unit	N/A
				Examiner Name	Not Yet Assigned
				Attorney Docket Number	62121(70904)
Sheet	1	of	1		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	AA	US-5,633,737	05/1997	Tanaka et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ^o
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	BA	JP-11-338379	12/1999			✓
	BB	JP-2001-341210	12/2001			✓
	BC	JP-2001-255660	09/2001			✓
	BD	JP-09-090336	04/1997			✓
	BE	JP-2000-098102	04/2000			✓

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ²	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	CA	Fujita et al., "Fabrication method of double micro lens array substrate," Japan Society of Applied Physics.	
	CB	Okada et al., "31a-W-11 Fabrication of double micro lens arrays using a self-alignment exposure method," Japan Society for Precision Engineering.	
	CC	Kitamura et al., "Fabrication Method of Double Micro Lens Array Using Self-Alignment Technology," 9th Microoptics Conference (MOC '03) Tokyo, October 29-31, 2003, pp. 114-17.	
	CD	Kitamura et al., "Fabrication Method of Double-Microlens Array Using Self-Alignment Technology," Japanese Journal of Applied Physics, Vol. 43, No. 8B, 2004.	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Examiner Signature		Date Considered	
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